07/22/04 6047-61466 295312



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re application of: Agarwal et al.

Application No. 10/002,779

Filed: October 29, 2001 Confirmation No. 6254

METHODS FOR FORMING AND For:

> INTEGRATED CIRCUIT STRUCTURES CONTAINING RUTHENIUM AND

TUNGSTEN CONTAINING LAYERS

Examiner: David Vu

Art Unit: 2818

Attorney Reference No. 6047-61466

COMMISSIONER FOR PATENTS P.O. BOX 1450 ALEXANDRIA, VA 22313-1450

CERTIFICATE OF MAILING

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: COMMISSIONER FOR PATENTS. P.O. BOX 1450, ALEXANDRIA, VA 22313-1450 on the date shown below.

Attorney for Applicant(s)

Date Mailed July 22, 2004

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT **PURSUANT TO 37 C.F.R. § 1.97(b)**

Listed on the accompanying form PTO-1449 and enclosed herewith are several Englishlanguage. Applicants respectfully request that these documents be listed as references cited on the issued patent.

This Information Disclosure Statement is being filed after the mailing date of a first Office action on the merits, and before the mailing date of a final Office action, a Notice of Allowance, or an action that otherwise closes prosecution, and a \$180.00 fee under 37 C.F.R. § 1.17(p) may be charged to Deposit Account No. 02-4550. If the Patent Office determines that an additional fee is required for to file this Information Disclosure Statement, please charge any such fees to Deposit Account No. 02-4550. Two copies of this Information Disclosure Statement are enclosed.

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The filing of this IDS shall not be construed to be an admission that the information cited in the statement is, or is considered to be, prior art or otherwise material to patentability as defined in 37 C.F.R. §1.56.

Respectfully submitted,

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MATION DISCLOSURE STATEMENT

BY APPLICANT

Attorney Docket Number	6047-61466
Application Number	10/002,779
Filing Date	October 29, 2001
First Named Inventor	Agarwal et al.
Art Unit	2818
Examiner Name	David Vu

U.S. PATENT DOCUMENTS

Examiner's Initials*	Cite No. (optional)	Number	Date	Name
		5,466,310	11/1995	Ninham et al.
		6,364,813	11/1994	Koh

EXAMINER	DATE
SIGNATURE:	CONSIDERED:

^{*} Examiner: Initial if reference considered, whether or not in conformance with MPEP 609. Draw line through cite if not in conformance and not considered. Include copy of this form with next communication to applicant.